

## SPECIFICATION

Please rewrite the title as —METHOD OF FACBRICATING A CAPACITOR HAVING SIDEWALL SPACE PROTECTING THE DIELECTRIC LAYER—.

At page 18 of the specification, please rewrite the Abstract as follows:

A capacitor structure ~~includes~~ is fabricated by forming a bottom plate, forming a dielectric layer overlaying the bottom plate, and forming a top plate over the,~~and a dielectric layer between the bottom and top plates.~~ In addition, at least one insulating sidewall spacer that protects the dielectric layer during processing is formed along the perimeter of the top plate and overlaying a portion of the dielectric layer.